



#4/DRAWINGS
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE JUL 17 2002

TECHNOLOGY CENTER 280

In re application of:
Kajiwara et al.

Art Unit: not assigned

Serial No. 09/874,174
Filed: June 4, 2001

Examiner: not assigned

For:

Chemical Mechanical Polishing Apparatus
And Method Having A Retaining Ring With
A Contoured Surface

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being sent via U.S. Mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231, on August 24, 2001.

Signed:

Kathleen M. Smith
Kathleen M. Smith

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SUBMISSION OF FORMAL DRAWINGS

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231
ATTN: OFFICIAL DRAFTSPERSON

Sir:

Enclosed please find 7 sheets of formal drawings for review by the Patent and Trademark Office:

- ☒ to be substituted in place of the informal drawings filed with this application.
- ☐ in connection with the Notice of Patent Drawing Review (Attachment to Paper No. 5).
- ☐ in connection with the Notice of Allowance mailed
- ☐ incorporating the drawings corrections filed on

The Commissioner is hereby authorized to charge any additional fees which may be required by this paper, or to credit any overpayment, to Deposit Account No. 06-1300 (No. A-70092/RMA)

Dated: August 24, 2001.

RESPECTFULLY SUBMITTED,

FLEHR HOHBACH TEST
ALBRITTON & HERBERT LLP

By

R. Michael Ananian

R. Michael Ananian
Reg. No. 35,050

4 Embarcadero Center Suite 3400